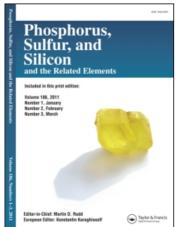
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Study of Fragmentation Reactions of Highly Sterically Hindered Organosilicon Compounds with Alcoholic Sodium Alkoxides

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The compounds $(Me_3Si)_3CSiXX'X''$ $[X=Me, X'=(C_6H_4Me-p), X''=I; X=Et, X'=X''=Cl; X=Bu, X'=X''=Cl]$ reacted with boiling RONa/ROH [R=Pr, iso-Pr, Bu, Et, Benzyl, iso-Amyl] to give the fragmentation products of the type $(Me_3Si)_2CHSiXX'(OR)$ and $Me_3SiCH_2SiXX'(OR)$ $[X=Me, X'=(C_6H_4Me-p)]$ or $(Me_3Si)_2CHSiX(OR)_2$ $[X=Et \ or \ Bu]$. Study of the products showed that alkoxides as nucleophile cannot attack the silicon center bearing the $(Me_3Si)_3C$ -group because of steric hindrance. It is suggested that the reaction proceeds through an elimination, analogous to the E2 elimination of alkyl halides, involving the synchronous attack of RO^- at a Me_3Si group, the liberation of X^- , and the formation of $(Me_3Si)_2C=SiXX'$.

Keywords Alkoxide; fragmentation; organosilicon; trisyl

INTRODUCTION

The tris(trimethylsilyl)methyl ligand, $(Me_3Si)_3C$, is a highly sterically hindered ligand in which three organosilyl substituents are attached to the central carbon atom. It is referred to as the "trisyl" ligand and commonly denoted by Tsi. A large number of metal compounds containing the bulky $(Me_3Si)_3C$ - group have been synthesized and their reactions have been studied. The presence of the trisyl ligand in organosilicon compounds of the type $(Me_3Si)_3CSiR_2X$ or $(Me_3Si)_3CSiRX_2$ [X=halogen] causes a very large steric hindrance toward the nucleophilic displacement of X. Therefore, these compounds undergo the direct biomolecular nucleophilic displacement of X

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only with difficulty, and this permits observations of other reactions not normally encountered. This is the case in the reactions with sodium alkoxides, which we describe below.

RESULTS AND DISCUSSION

The study began with $TsiSiMe(C_6H_4Me-p)I$, which was made as described previously by the treatment of $TsiSiMe(C_6H_4Me-p)H$ with one molar proportion of ICl in carbon tetrachloride at room temperature. When the compound TsiSiXX'X'' ($X = Me, X' = C_6H_4Me-p, X'' = I$) was treated for several hours with refluxing 2 M sodium alkoxide (NaOR) in alcohol (ROH), the product was of the type $(Me_3Si)_2CHSiXX'OR$ (Equation 1) or $Me_3SiCH_2SiXX'OR$ (Equation 2):

$$\begin{split} (Me_3Si)_3CSiXX'X'' + RONa + ROH &\rightarrow (Me_3Si)_2CHSiXX'(OR) \\ &\quad + Me_3SiOR + NaX'' \end{split} \tag{1}$$

$$(Me_3Si)_2CHSiXX'(OR) + RONa + ROH \rightarrow Me_3SiCH_2SiXX'OR \qquad (2)$$

The possible route for these products is shown in Scheme 1. The initial process is analogous to an E2 elimination from organic halides, but with an attack at the β -silicon rather than the β -hydrogen. Alkoxide as a nucleophile attacks at a Me₃Si bond rather than the electronically favored XX′SiX″ center, which can be attributed to the fact that attack at the former relieves steric strain. Therefore, the corresponding sila-olefin (Me₃Si)₂C=SiXX′ is obtained, which then rapidly adds alcohol to give the observed product (Me₃Si)₂CHSiXX′(OR) with less steric hindrance. The absence of the halide group in the newly obtained organosilicon compound causes an alkoxide attack at a Me₃Si bond to give a carbanion. The addition of alcohol to the carbanion results in Me₃SiCH₂SiXX′(OR) as a silyl ether compound.

Details of the reaction of TsiSiMe(C₆H₄Me-*p*)I in various alcoholic sodium alkoxides medium are given in Table I. With increasing

(a)
$$RO^ Me_3Si$$
— $C(SiMe_3)_2$ — $SiXX'$ — X'' \longrightarrow $ROSiMe_3 + (Me_3Si)_2C=SiXX' + $X''^ (Me_3Si)_2C=SiXX' + ROH$ \longrightarrow $(Me_3Si)_2CHSiXX'(OR)$$

(b) RO
$$Me_3Si$$
—CHSiMe $_3$ —SiXX'(OR) \longrightarrow CHSiMe $_3Si$ XX'(OR) + ROSiMe $_3$

CHSiMe $_3Si$ XX'(OR) + ROH \longrightarrow Me $_3Si$ CH $_2Si$ XX'(OR)

SCHEME 1

Alkoxide solution	Time (day)	Product	Yield (%)
ⁿ PrONa/ ⁿ PrOH (2.5 M)	5	$(Me_3Si)_2CHSiMe(C_6H_4Me-p)(O^nPr)$	28
ⁱ PrONa/ ⁱ PrOH (2.5 M)	18	$(Me_3Si)_2CHSiMe(C_6H_4Me-p)(O^iPr)$	34
ⁿ BuONa/ ⁿ BuOH (2.5 M)	6	$(Me_3Si)_2CHSiMe(C_6H_4Me-p)(O^nBu)$	24
PhCH ₂ ONa/PhCH ₂ OH (2.5 M)	20	$Me_3SiCH_2SiMe(C_6H_4Me-p)(OCH_2Ph)$	27
ⁱ AmONa/ ⁱ AmOH (2.5 M)	10	$Me_{3}SiCH_{2}SiMe(C_{6}H_{4}ME\text{-}p(O^{i}Am)$	32

TABLE I Reaction of TsiSiMe(C₆H₄Me-p)I With Alkoxides

bulkiness of the alkoxide groups, direct nucleophilic displacement was difficult and elimination—addition reactions were favored.

We next prepared $TsiSiEtCl_2$ by the reaction of TsiLi with $EtSiCl_3$ in THF. Then $TsiSiEtCl_2$ and $TsiSiBuCl_2$ ¹¹ were treated for several hours with 2 M or 1.5 M NaOR/ROH. The obtained products $(Me_3Si)_2CHSiEt(OR)_2$ and $(Me_3Si)_2CHSiBu(OR)_2$ showed that all the chlorine ligands have been displaced with alkoxide reagents. Table II shows details of the results.

The suggested mechanism for these reactions is shown in Scheme 2. These reactions confirmed the fragmentation mechanism that have been proposed by Eaborn,^{8,9} and some new organosilicon compounds were prepared.

(a)
$$RO^{-}$$
 $Me_3Si-C(SiMe_3)_2$ — $SiEtCl-Cl$ \longrightarrow $ROSiMe_3 + (Me_3Si)_2C=SiEtCl + Cl^{-}$ $(Me_3Si)_2C=SiEtCl + ROH$ \longrightarrow $(Me_3Si)_2CHSiEtCl(OR)$ (b) RO^{-} $(Me_3Si)_2CH-SiEt(OR)$ — Cl \longrightarrow $(Me_3Si)_2CHSiEt(OR)_2 + Cl^{-}$

SCHEME 2

EXPERIMENTAL

Solvents and Reagents

The reactions involving organolithium reagents and alkoxides were carried out under dry argon to exclude oxygen and moisture from the reaction systems. Solvents were dried by standard methods.

Spectra

 1 HNMR and 13 CNMR spectra were run on a Bruker 400 MHz spectrometer at room temperature using CDCl $_3$ as a solvent containing

TsiSiXCl ₂	Alkoxide solution	Time (h)	Product	Yield
			(2.5 (Q1) (Q1) (Q1) (Q1)	. ,
_	EtONa/EtOH (2.0M) ⁿ BuONa/ ⁿ BuOH (1.5M)	24 48	(Me ₃ Si) ₂ CHSiEt(OEt) ₂ (Me ₃ Si) ₂ CHSiEt(O ⁿ Bu) ₂	48 58
_	PhCH ₂ ONa/PhCH ₂ OH (1.5 M)		(Me ₃ Si ₂ CHSiEt(OCH ₂ Ph) ₂	
_	ⁿ PrONa/ ⁿ PrOH (2.0 M)	48	$(Me_3Si_2CHSiEt(O^nPr)_2$	35
TsiSiBuCl ₂	$^{\mathrm{i}}\mathrm{PrONa}/^{\mathrm{i}}\mathrm{PrOH}\ (2.0\ \mathrm{M})$	48	$(Me_3Si)_2CHSiBu(O^iPr)_2$	45

TABLE II Reaction of TsiSiXCl₂ With Alkoxides

tetramethyl silane as a reference. Mass spectra were obtained by the use of a Shimadzu QP-100X spectrometer at 70 eV. Elemental analyses were carried out with a Heareus CHN-ORAPID instrument. The melting point was determined on an electrothermal 9100-digital apparatus.

Reaction of TsiSi(C₆H₄Me-p)Mel With NaOⁿPr/ⁿPrOH

A solution of $TsiSi(C_6H_4Me-p)Mel$ (0.2 g, 0.4 mmol) in 2.5 M $NaO^nPr/^nPrOH$ (50 mL) was refluxed for 5 days and then added to water. Extraction was carried out with n-hexane (50 mL) and the organic layer was washed several times with water. The organic layer was separated, dried (Na_2SO_4), filtered, and evaporated. The liquid residue was purified by TLC (silicagel, 4:1 dichloromethane:n-hexane as an eluent) to give ($Me_3Si)_2CHSi(C_6H_4Me-p)Me(O^nPr)$.

 $^{\bar{1}}$ HNMR (CDCl₃), -0.28 (s, 1H, CH), 0.21 (s, 18H, Me₃Si), 0.42 (s, 3H, SiMe), 0.85 (t, 3H, CH₃), 1.5 (m, 2H, CH₂), 2.4 (s, 3H, Me-aryl), 3.5 (t, 3H, OCH₂), 7.2–7.5 ppm (m, 4H, aryl-H); 13 CNMR (CDCl₃): -2.3 (1C, CH), 0.11 (6C, SiMe₃), 1.8 (1C, SiMe), 20.5 (1C, Me-aryl), 24.7 (1C, CH₃), 49.9 (1C, CH₂), 63.7 (1C, OCH₂), 127.4–132.5 ppm (6C, aryl); m/z (EI): 352 (2%, [M]⁺), 337 (30%, [M-Me]⁺), 265(77%), 131 (100%), 73 (10%).

Reaction of TsiSi(C₆H₄Me-p)Mel With NaOⁱPr/ⁱPrOH

 $TsiSi(C_6H_4Me-p)MeI$ (0.2 g, 0.4 mmol) was refluxed in 2.5 M $NaO^iPr^{ji}PrOH$ (50 mL) for 18 days. n-Hexane (50 mL) was added and the organic layer washed several times with water. The organic layer was separated, dried (Na_2SO_4), filtered, and evaporated. The liquid residue was purified by TLC (silicagel, 4:1 dichloromethane:n-hexane as an eluent) to give ($Me_3Si)_2CHSi(C_6H_4Me-p)Me(O^iPr)$.

 1 HNMR (CDCl₃), -0.23 (s, 1H, CH), 0.22 (s, 18H, Me₃Si), 0.42 (s, 3H, SiMe), 1.1 (d, 6H, CH₃), 2.4 (s, 3H, Me-aryl), 3.9 (m, 1H, OCH), 7.2–7.5 ppm (m, 4H, aryl-H); 13 CNMR (CDCl₃): -1.7 (1C, CH), 0.18

(6C, SiMe₃), 2.5 (1C, SiMe), 21.1 (1C, Me-aryl), 24.6 (2C, CH₃), 64.1 (1C, OCH), 127–138 ppm (6C, aryl); m/z (EI): 351 (3%, [M-1]⁺), 337 (25%, [M-Me]⁺), 265(79%), 223 (100%), 131 (80%).

Reaction of TsiSi(C₆H₄Me-p)Mel With NaOⁿBu/ⁿBuOH

A solution of $TsiSi(C_6H_4Me-p)MeI$ (0.2 g, 0.4 mmol) in 2.5 M NaOnBu/nBuOH (50 mL) was refluxed for 6 days. Then n-hexane (50 mL) was added and the organic layer washed several times with water. The organic layer was separated, dried (Na₂SO₄), filtered, and evaporated. The liquid residue was purified by TLC (silicagel, 4:1 dichloromethane:n-hexane as an eluent) to give (Me₃Si₎₂CHSi(C₆H₄Me-p)Me(OⁿBu).

 $^{1}\text{HNMR}$ (CDCl₃), -0.38 (s, 1H, CH), 0.21 (s, 18H, Me₃Si), 0.42 (s, 3H, SiMe), 0.91 (t, 3H, CH₃), 1.3–1.5 (m, 4H, CH₂–CH₂), 2.4 (s, 3H, Mearyl), 3.6 (t, 3H, OCH₂), 7.3–7.5 ppm (m, 4H, aryl-H); $^{13}\text{CNMR}$ (CDCl₃): -2.3 (1C, CH), 0.15 (6C, SiMe₃), 2.4 (1C, SiMe), 12.9 (1C, CH₃), 18.4 (1C, CH₂), 20.5 (1C, Me-aryl), 33.7 (1C, CH₂), 61.6 (1C, OCH₂), 127.5–138.5 ppm (6C, aryl); m/z (EI): 366 (10%, [M]+), 351 (5%, [M-Me]+), 293 (22%), 131 (100%), 73 (10%).

Reaction of TsiSi(C₆H₄Me-p)Mel With NaOCH₂Ph/PhCH₂OH

 $TsiSi(C_6H_4Me-p)MeI\ (0.2~g,\ 0.4~mmol)$ was refluxed in 2.5 M $NaOCH_2Ph/PhCH_2OH\ (50~mL)$ for 20 days. The mixture then was worked up, extracted with n-hexane (50 mL), and washed several times with water. The organic layer was separated, dried $(Na_2SO_4),$ filtered, and evaporated. The liquid residue was purified by TLC (silicagel, 4:1 dichloromethane:n-hexane as an eluent) to give $Me_3SiCH_2Si(C_6H_4Me-p)Me(OCH_2Ph).$

 $^{1}\text{HNMR}$ (CDCl₃), -0.12 (s, 2H, SiCH₂), 0.022 (s, 9H, Me₃Si), 0.41 (s, 3H, SiMe), 2.4 (s, 3H, Me-aryl), 4.6 (s, 2H, OCH₂), 7.2–7.5 ppm (m, 9H, aryl-H); m/z (EI): 328 (2%, [M]⁺), 313 (10%, [M–Me]⁺), 241(12%), 131 (100%), 91 (62%).

Reaction of TsiSi(C₆H₄Me-p)Mel With NaOⁱAm/ⁱAmOH

A solution of $TsiSi(C_6H_4Me-p)MeI$ (0.2 g, 0.4 mmol) in 2.5 M NaO^iAm^jAmOH (50 mL) was refluxed for 10 days. Then n-hexane (50 mL) was added and the organic layer washed several times with water. The organic layer was separated, dried (Na_2SO_4), filtered, and evaporated. The liquid residue was purified by TLC (silicagel, 5:1

dichloromethane:n-hexane as an eluent) to give $Me_3SiCH_2Si(C_6H_4Me-p)Me(O^iAm)$.

 $^{1}HNMR~(CDCl_{3}),\,-0.49~(s,\,2H,\,SiCH_{2}),\,0.07~(s,\,9H,\,Me_{3}Si),\,0.41~(s,\,3H,\,SiMe),\,0.89~(d,\,6H,\,CH_{3}),\,1.3~(m,\,2H,\,CH_{2}),\,1.6~(m,\,1H,\,CH),\,2.4~(s,\,3H,\,Me-aryl),\,3.6~(t,\,2H,\,OCH_{2}),\,7.3-7.5~ppm~(m,\,4H,\,aryl-H);\,^{13}CNMR~(CDCl_{3}):\,-2.34~(1C,\,SiCH_{2}),\,0.12~(3C,\,SiMe_{3}),\,2.4~(1C,\,SiMe),\,18.9~(2C,\,CH_{3}),\,21.1~(1C,\,CH),\,22.5~(1C,\,Me-aryl),\,40.6~(1C,\,CH_{2}),\,60.1~(1C,\,OCH_{2}),\,127.5-138.2~ppm~(6C,\,aryl);\,m/z~(EI):\,294~(50\%,\,[M-Me]^+),\,223~(68\%,\,[M-O^{i}Am]^+),\,131~(100\%),\,105~(58\%),\,73~(72\%).$

Preparation of TsiSiEtCl₂

EtSiCl $_3$ (8.17 g, 50 mmol) was added dropwise with stirring to a solution of TsiLi (50 mmol) in THF (50 mL) that had been made by the reaction of TsiH (11.5 g, 50 mmol) with MeLi (0.84 g, 120 mmol). The mixture was refluxed for 30 min, aqueous NH $_4$ Cl was added, and the organic layer was extracted with Et $_2$ O. The extract was dried (Na $_2$ SO $_4$), filtered, and evaporated. The solid residue was recrystallized from EtOH to give TsiSiEtCl $_2$ (62%), m.p. 308°C.

 $^{1}HNMR\ (CDCI_{3})\ 0.34\ (s,\ 27H,\ Me_{3}Si),\ 1-1.25\ ppm\ (m,\ 5H,\ CH_{2}CH_{3});\\ ^{13}CNMR\ (CDCl_{3})\ 1.7\ (1C,\ C-SiMe_{3}),\ 3.8\ (9C,\ Me_{3}Si),\ 6.0\ (1C,\ CH_{3}),\\ 16.2\ ppm\ (1C,\ CH_{2});\ m/z\ (EI):\ 344\ (100\%,\ [M-Me]^{+}),\ 330\ (5\%,\ [M-Et]^{+}),\ 140\ (5\%),\ 128\ (20\%),\ 73\ (20\%).\ (Found:\ C,\ 39.8;\ H,\ 8.8.\ C_{12}H_{32}Cl_{2}Si_{4}Calc.:\ C,40.1;\ H,\ 8.9\%).$

Reaction of TsiSiEtCl₂ With NaOEt/EtOH

TsiSiEtCl₂ (1 g, 2.78 mmol) was refluxed in 2 M NaOEt/EtOH (50 mL) for 24 h and added to n-hexane (50 mL). The organic layer was washed several times with water and separated. Then the organic layer was dried (Na₂SO₄), filtered, and evaporated. The liquid residue was purified by TLC (silicagel, 9:1 n-hexane:dichloromethane as eluent) to give $(Me_3Si)_2CHSiEt(OEt)_2$.

 $^1HNMR~(CDCl_3),~-0.62~(s,~1H,~SiCH),~0.12~(s,~18H,~Me_3Si),~0.51–1.5~(m,~5H,~Et),~1–1.5~(m,~6H,~Me-C),~3.6~ppm~(q,~4H,~OCH_2);~^{13}CNMR~(CDCl_3):~0.12~(1C,~SiCH),~1.9~(6C,~SiMe_3),~5.8,~10.3~(2C,~Et),~31.3~(2C,~Me),~59.2~ppm~(2C,~OCH_2);~m/z~(EI):~306~(45\%,~[M]^+),~305~(83\%,~[M-1]^+),~291~(100\%,~[M-Me]^+),~277~(40\%),~217~(32\%),~159~(49\%),~144~(55\%),~73~(22\%).~(Found:~C,~50.5;~H,~10.4.~C_{13}H_{34}Si_3~Calc.:~C,~51.0;~H,~11.1\%).$

Reaction of TsiSiEtCl₂ With NaOⁿBu/ⁿBuOH

A solution of TsiSiEtCl₂ (1 g, 2.78 mmol) in 1.5 M NaOⁿBu/ⁿBuOH (50 ML) was refluxed for 48 h. n-Hexane (50 mL) was added and the

organic layer washed several times with water. The n-hexane solution was separated, dried (Na₂SO₄), filtered, and evaporated. The liquid residue was purified by TLC (silicagel, 2:3 n-hexane:dichloromethane as an eluent) to give (Me₃Si)₂CHSiEt(OⁿBu)₂.

 $^{1}HNMR~(CDCl_{3}),~-0.45~(s,~1H,~SiCH),~0.11~(s,~18H,~Me_{3}Si),~0.65~(q,~2H,~SiCH_{2}),~0.86-1.2~(m,17H,~Si-C-Me~and~O-C-CH_{2}CH_{2}CH_{3}),~3.7~ppm~(t,~4H,~OCH_{2});~^{13}CNMR~(CDCl_{3}):~-1.4~(1C,~SiCH),~1.7~(6C,~SiMe_{3}),~5.1,~12.8~(2C,~Si-Et),~6.1,~18,~33.8,~61~ppm~(8C,~OBu);~m/z~(EI):~278~(2\%,~[M]^{+}),~348~(52\%,~[M-Me]^{+}),~333~(59\%,~[M-Et]+),~219~(75\%),~216~(74\%),~203~(100\%),~187~(68\%),~73~(50\%).$

Reaction of TsiSiEtCl₂ with NaOCH₂Ph/PhCH₂OH

TsiSiEtCl₂ (1 g, 2.78 mmol) was refluxed in 1.5 M NaOCH₂Ph/PhCH₂OH (50 mL) for 72 h, and then added to n-hexane (50 mL). The organic layer was washed several times with water, and then separated. The organic layer was dried (Na₂SO₄), filtered, and evaporated to give a liquid an residue. The latter was subjected to TLC (silicagel, 7:1 n-hexane:dichloromethane as an eluent) to give (Me₃Si)₂CHSiEt(OCH₂Ph)₂.

¹HNMR (CDCl₃), -0.65 (s, 1H, SiCH), 0.12 (s, 18H, Me₃Si), 0.6–1.4 (m, 5H, Et), 4.3 (s, 4H, OCH₂), 7.2–8.1 ppm (m, 10H, aryl-H); ¹³CNMR (CDCl₃): 0.03 (1C, SiCH), 1.6 (6C, SiMe₃), 5.1, 10.5 (2C, Si-Et), 49.2 (2C, OCH₂), 127.6–137.2 ppm (12C, aryl); m/z (El): 415 (10%, [M-Me]⁺), 401 (8%, [M-Et]⁺), 400 (22%), 323 (38%), 339 (20%), 91 (100%), 73 (53%).

Reaction of TsiSiBuCl₂ With NaOⁿPr/ⁿPrOH

A solution of TsiSiBuCl $_2$ (1 g, 2.66 mmol) in 2 M NaOⁿPr/ⁿPrOH (50 ML) was refluxed for 48 h. The solution was added to n-hexane (50 Ml) and the organic layer washed several times with water. The organic layer was separated, dried (Na $_2$ SO $_4$), filtered, and evaporated. The residue was purified by TLC (silicagel, 9:2 n-hexane:dichloromethane as an eluent) to give (Me $_3$ Si) $_2$ CHSiBu(OⁿPr) $_2$.

 $^{1}HNMR~(CDCl_{3}),\,-0.6~(s,\,1H,\,CH),\,0.12~(s,\,18H,\,Me_{3}Si),\,0.5-1.5~(m,\,19H,\,Bu~and~O-C-CH_{2}CH_{3}),\,4.2~ppm~(t,\,3H,\,OCH_{2});\,m/z~(El):\,362~(2\%,\,[M]^{+}),\,347~(10\%,\,[M-Me]^{+}),\,305~(24\%,\,[M-Bu]^{+}),\,263~(50\%),\,187~(65\%),\,73~(100\%).~(Found:\,C,\,56.9;\,H,\,11.2.\,C_{17}H_{42}O_{2}Si_{3}~Calc.:\,C,\,56.3;H,11.6\%).$

Reaction of TsiSiBuCl₂ With NaOⁱPr/PrOH

A solution of TsiSiBuCl₂ (1 g, 2.66 mmol) in 2 M NaOⁱPr/ⁱPrOH (50 mL) was refluxed for 48 h. The solution was added to n-hexane (50 mL)

and the organic layer washed several times with water. The organic layer was separated, dried (Na₂SO₄), filtered, and evaporated to give a liquid residue. The latter was purified by TLC (silicagel, 9:1 n-hexane:dichloromethane as an eluent) to give (Me₃Si)₂CHSiBu(OⁱPr)₂.

 $^{1}HNMR~(CDCl_{3}),\,-0.64~(s,\,1H,\,CH),\,0.13~(s,\,18H,\,Me_{3}Si),\,0.5-1.5~(m,\,21H,\,Bu~and~O-C-CH_{3}),\,4.1~ppm~(m,\,2H,\,OCH);\,m/z~(EI):\,347~(15\%,\,[M-Me]^{+}),\,305~(22\%,\,[M-Bu]^{+}),\,263(49\%),\,246(25\%),\,189~(62\%),\,73~(100\%).~(Found:~C,\,55.8;~H,\,12.1.~C_{17}H_{42}O_{2}Si_{3}~Calc.:~C,\,56.3;~H,\,11.6\%).$

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